

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/549,865  
First Named Inventor: Victor Higgs  
Filed: July 28, 2006  
Title: Detection Method and Apparatus Metal Particulates on Semiconductors  
TC/A.U. 2886 Examiner: Isiaka O. Akanbi  
Atty Docket: NAN165 US (8037) Confirmation No.: 4772

Saratoga, California  
August 27, 2008

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

This Response to Office Action is responsive to the May 27, 2008, Office Action, which has a statutorily shortened period for response that ends August 27, 2008. The Commissioner is hereby authorized by the undersigned to debit Deposit Account 50-2263 for any underpayment or any additional necessary fees. Please enter the following amendments before taking action on the merits of the above-referenced application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

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